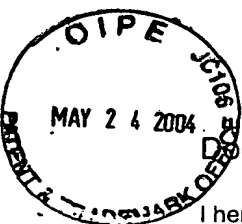


IFW



Docket No.: P2002,0889

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date indicated below.

By: 

Date: May 20, 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No.	:	10/686,848	Confirmation No: 1741
Applicant	:	Martin Rößiger et al.	
Filed	:	October 16, 2003	
Title	:	Method for Aligning and Exposing a Semiconductor Wafer	
Art Unit	:	2811	
Examiner	:	to be assigned	
Docket No.	:	P2002,0889	
Customer No.	:	24131	

INFORMATION DISCLOSURE STATEMENT

Hon. Commissioner for Patents

Sir:

In accordance with 37 C.F.R. 1.98 copies of the following patents and/or publications are submitted herewith:

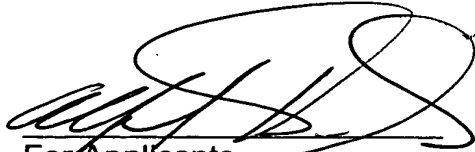
United States Patent No. 5,451,479 (Ishibashi), dated September 19, 1995, and corresponding German Patent DE 44 14 369 C2, dated October 27, 1994;

German Examination Report dated April 22, 2004.

In accordance with 37 C.F.R. 1.97(e) the undersigned herewith states that each item of information contained in the information disclosure statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement.

As per the Notice in 1273 OG 55 (August 5, 2003) no copies of any above-mentioned U.S. patents and U.S. patent application publications are submitted for any application filed after June 30, 2003.

Respectfully submitted,

A handwritten signature in black ink, appearing to read 'Alfred K. Dassler', is written over the text 'For Applicants'.

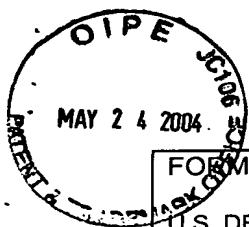
For Applicants

**Alfred K. Dassler**  
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FORM PTO-1449 (SUBSTITUTE)

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICEINFORMATION DISCLOSURE  
STATEMENT BY APPLICANT  
(37 CFR 1.98(b))Attorney Docket No.:  
P2002,0889Applic. No.  
10/686,848

Applicant

Martin Rössiger et al.

Filing Date  
October 16, 2003Group Art Unit  
2811

## U.S. PATENT DOCUMENTS

EXAMINER INITIALS		PATENT NO.	DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE
	A	5,451,479	09/19/95	Ishibashi			
	B						
	C						
	D						
	E						
	F						
	G						
	H						
	I						

## FOREIGN PATENT DOCUMENT

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB CLASS	TRANSL. YES   NO
	J	44 14 369 C2	10/27/94	Germany			
	K						
	L						
	M						
	N						

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

	O	
	P	

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.